

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant :	Hongyong Zhang	Art Unit :	2814
Serial No. :	09/362,808	Examiner :	Shrinivas H. Rao
Filed :	July 28, 1999	Conf. No. :	7320
Title :	METHOD OF FABRICATING SEMICONDUCTOR DEVICE		

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Commissioner for Patents
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INFORMATION DISCLOSURE STATEMENT

Applicants request consideration of the references listed on the attached PTO-1449 form. Under 37 C.F.R. § 1.98 (a)(2)(ii), only copies of foreign patent documents and/or non-patent literature are enclosed. Copies of any listed U.S. patents or U.S. patent application publications can be provided upon request.

The references included in this information disclosure statement were cited in U.S. Application Serial No. 11/275,021, which is directed to subject matter similar to that of the present application.

This filing is being made with the filing of a Request for Continued Examination. No fee is required.

Respectfully submitted,

Date: 10/31/07


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